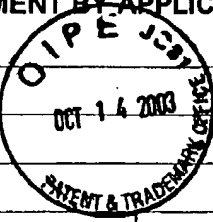


U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)					Docket No. 7125/CMP/CMP/RKK		Serial No. 10/621,303	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)					Applicant Olgado, D.		Confirmation No.:	
Examiner					Filing Date July 16, 2003		Group 3723	



U.S. Patent Documents							
*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
J.A.	A1	5,329,732	07/19/1994	Karlsrud et al.	451	289	
	A2	5,738,574	04/14/1998	Tolles et al.	451	288	
	A3	5,762,543	6/09/1998	Kasprzyk et al.	451	262	
	A4	5,934,984	08/10/1999	Togawa et al.	451	288	
	A5	5,947,802	09/07/1999	Zhang et al.	451	334	
	A6	6,074,275	6/13/2000	Yashiki et al.	451	5	
	A7	2003/0003848	01/02/2003	Tobin	451	11	08/27/2002
	A8	09/748,552		Sommer et al.			11/22/2000
	A9						
	A10						

Foreign Patent Documents								
*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation/Abstract	
							YES	NO
J.A.	B1	0 347 718	12/27/1989	EPO	H01L	21/00	<input type="checkbox"/>	<input type="checkbox"/>
	B2	99/1022	08/19/1999	WIPO	B08B	3/04	<input type="checkbox"/>	<input type="checkbox"/>
	B3	1,323,350	07/15/1987	SU	B24B	31/00	<input checked="" type="checkbox"/>	<input type="checkbox"/>
	B4						<input type="checkbox"/>	<input type="checkbox"/>
	B5						<input type="checkbox"/>	<input type="checkbox"/>

OTHER ART	
*Examiner Initial	Including Author, Title, Date, Pertinent Pages, Etc.
	C1
	C2
	C3

Examiner <i>Jacob Adams Jr</i>	Date Considered <i>12/17/04</i>
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.

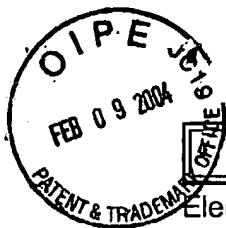


ELECTRONIC INFORMATION DISCLOSURE STATEMENT


Electronic Version v18

Stylesheet Version v18.0

Title of Invention	LOAD CUP FOR CHEMICAL MECHANICAL POLISHING																				
<p>Application Number: 10/621303 </p> <p>Confirmation Number: 2216</p> <p>First Named Applicant: Donald Olgado</p> <p>Attorney Docket Number: 7125/CMP/CMP</p> <p>Art Unit: 3723</p> <p>Search string: (5934984).pn.</p> <p>US Patent Documents</p> <p>Note: Applicant is not required to submit a paper copy of cited US Patent Documents</p> <table border="1"><thead><tr><th>init</th><th>Cite.No.</th><th>Patent No.</th><th>Date</th><th>Patentee</th><th>Kind</th><th>Class</th><th>Subclass</th></tr></thead><tbody><tr><td>N.A.</td><td>1</td><td>5934984</td><td>1999-08-10</td><td>Togawa et al.</td><td>B1</td><td>451</td><td>288</td></tr></tbody></table> <p>Signature</p> <table border="1"><thead><tr><th>Examiner Name</th><th>Date</th></tr></thead><tbody><tr><td>Jacob Ackun JR.</td><td>12/17/04</td></tr></tbody></table>		init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass	N.A.	1	5934984	1999-08-10	Togawa et al.	B1	451	288	Examiner Name	Date	Jacob Ackun JR.	12/17/04
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass														
N.A.	1	5934984	1999-08-10	Togawa et al.	B1	451	288														
Examiner Name	Date																				
Jacob Ackun JR.	12/17/04																				

**TRANSMITTAL**

Electronic Version v1.1
Stylesheet Version v1.1.0

Title of Invention	LOAD CUP FOR CHEMICAL MECHANICAL POLISHING									
<p>Application Number: 10/621303 </p> <p>Date: 2003-07-16</p> <p>First Named Applicant: Donald Olgado</p> <p>Confirmation Number: 2216</p> <p>Attorney Docket Number: 7125/CMP/CMP</p>										
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<table border="1"><thead><tr><th>Submitted by:</th><th>Elec. Sign.</th><th>Sign. Capacity</th></tr></thead><tbody><tr><td>Keith P Taboada Registered Number: 45150</td><td>/Keith Taboada/</td><td>Attorney</td></tr></tbody></table>			Submitted by:	Elec. Sign.	Sign. Capacity	Keith P Taboada Registered Number: 45150	/Keith Taboada/	Attorney		
Submitted by:	Elec. Sign.	Sign. Capacity								
Keith P Taboada Registered Number: 45150	/Keith Taboada/	Attorney								
<table><tr><td>Documents being submitted</td><td>Files</td></tr><tr><td>us-ids</td><td>APPM7125-usidst.xml</td></tr><tr><td></td><td>us-ids.dtd</td></tr><tr><td></td><td>us-ids.xsl</td></tr></table>			Documents being submitted	Files	us-ids	APPM7125-usidst.xml		us-ids.dtd		us-ids.xsl
Documents being submitted	Files									
us-ids	APPM7125-usidst.xml									
	us-ids.dtd									
	us-ids.xsl									
Comments										



Electronic Filing System (EFS) Data
Electronic Patent Application Submission
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EFS ID: 55257
Application ID: 10621303
Title of Invention: LOAD CUP FOR CHEMICAL
MECHANICAL POLISHING
First Named Inventor: Donald Olgado
Domestic/Foreign Application: Domestic Application
Filing Date: 2003-07-16
Effective Receipt Date: 2004-02-09
Submission Type: Information Disclosure
Statement
Filing Type:
Confirmation number: 2216
Attorney Docket Number: 7125/CMP/CMP



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